



PATENT

Docket No. 299002052200

Client Ref.: F5-0136063/98R00651/US/END

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Taryara Alcaraz

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Koji TAKAHASHI and Hidenori
KAWANISHI

Serial No.: 09/786,977

Filing Date: June 7, 2001

For: METHOD FOR FORMING COMOUND
SEMICONDUCTOR LAYER AND
COMPOUND SEMICONDUCTOR
APPARATUS

Examiner: J. Brophy

Group Art Unit: 2822

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AMENDMENT UNDER 37 C.F.R. §1.111

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

This is in response to the Office Action dated December 4, 2002 (Paper No. 9) for which a response was due on March 4, 2003 and for which a one month extension of time is also requested to extend the time for response from March 4, 2003 to April 4, 2003. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein is respectfully requested.

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